

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT****Complete if Known**

Application No.	10/039,111
Filing Date	January 4, 2002
First Named Inventor	Venkatesh R. Iyer
Art Unit	2145
Examiner Name	Jeffrey R. Swearingen
Attorney Docket Number	24523-09627

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**U.S. PATENT DOCUMENTS**

U.S. PATENT DOCUMENTS				
Examiner Initials*	Cite No. <sup>1</sup>	Document No. Number – Kind Code <sup>2</sup> (if known)	Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		US-		
		US-		
		US-		

**FOREIGN PATENT DOCUMENTS**

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Country Code <sup>3</sup> – Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T <sup>6</sup>

**OTHER REFERENCES – NON-PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>6</sup>
/J.S./	C1	BIERMAN, A. et al., Internet Draft: "Remote Monitoring MIB Extensions for Identifying Application Protocol Verbs," November 25, 2000, 22 pages, [online] Retrieved from the Internet<URL: <a href="http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-01">http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-01</a> >	
/J.S./	C2	BIERMAN, A. et al., Internet Draft: "Remote Monitoring MIB Extensions for Identifying Application Protocol Verbs," July 17, 2001, 23 pages [online] Retrieved from the Internet<URL: <a href="http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-02">http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-02</a> >	
/J.S./	C3	BIERMAN, A. et al, Internet Draft: "Remote Monitoring MIB Extensions for Identifying Application Protocol Verbs," July 14, 2000, 21 pages, [online] Retrieved from the Internet<URL: <a href="http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-00">http://tools.ietf.org/html/draft-ietf-rmonmib-appverbs-00</a> >	

Examiner Signature	/Jeffrey Swearingen/	Date Considered	06/17/2008
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609.

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